



## Agenda EDS User School

Duration: 3 days  
Location: Bruker Nano GmbH, Am Studio 2D, 12489 Berlin-Adlershof, Germany  
Time frame: 9:30am – 4:30pm (lunch break 12:30 – 1:30pm)

### Day 1

- 9:30am**                    **Principles of Electron Beam Microanalysis**  
Beam-specimen interactions  
Origin of Bremsstrahlung and characteristic peaks  
Moseley's law  
Characteristic peaks: K-, L-, and M-series  
Spatial resolution - and excitation range in EDS analysis  
Energy resolution
- 11am**                        **System parameters**  
EDS and SEM - fundamentals  
Detector and signal processing  
Signal processing unit settings  
Microscope settings (accelerating voltage, tilt, working distance)  
Artefacts (escape, tail, shelf, shift and pile-up)
- 12:30-1:30pm**            **Lunch break**
- 1:30pm**                    **Spectra acquisition (part I)**  
Energy channel calibration (Mn K $\alpha$  resolution)  
Identification (manually, finder, automatically)  
Options (sputtering correction, online quantification)  
Correction possibilities (tilt, Duane/Hunt limit)  
Spectra comparison (manually, automatically)  
Spectra arithmetic  
Storage of spectra data (storage of single files, project management)
- Spectra acquisition (part II)**  
Method editor  
Identification via deconvolution
- 3pm**                        **Exercices**  
Element identification (Minerals)

## Day 2

<b>9am</b>	<b>Quantification (theory)</b> Identification, Bremsstrahlung (calculation), Deconvolution models (Bayes – Fit), Quantification (standardless vs. standardbased), Correction methods (ZAF and $\Phi(\rho z)$ ), Solid samples – rough surfaces, Thin layers [Cliff-Lorimer quantification (TEM)]
<b>11am</b>	<b>Quantification (practice)</b> Generation of user specific analysis routines Identification and quantification (Cr-Ni-steel)
<b>12:30-1:30pm</b>	<b>Lunch break</b>
<b>1:30pm</b>	<b>Training exercises on the SEM</b> <b>Object analysis</b> Automatic multi-point analysis (regular and statistical) Analysis of rectangles, ellipses and polygons  <b>Line scan</b> (qualitative, quantitative)

## Day 3

<b>9am</b>	<b>Mapping, quantitative mapping and HyperMapping</b> Applications of different Mapping modes, Maximum Pixel Spectrum, Automatic phase analysis Drift correction, Phase diagram presentation <b>QMap exercise</b>
<b>11:30am</b>	<b>Training exercises on the SEM</b> <b>Mapping</b>
<b>12:30-1:30pm</b>	<b>Lunch break</b>
<b>1:30pm</b>	<b>Typical mistakes during EDS analysis</b> & user questions
<b>2:15pm</b>	<b>Training exercises on the SEM</b> <b>Mapping</b>

Hand out of certificates

**Per request:**      **Special functions**